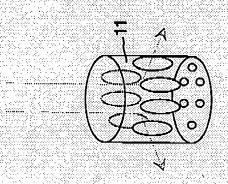


THIN-FILM DEPOSITION APPARATUS
Hiroshi SHINRIKI, et al.
Appl. No.: Unknown Atty Docket: ASMJP.149AUS

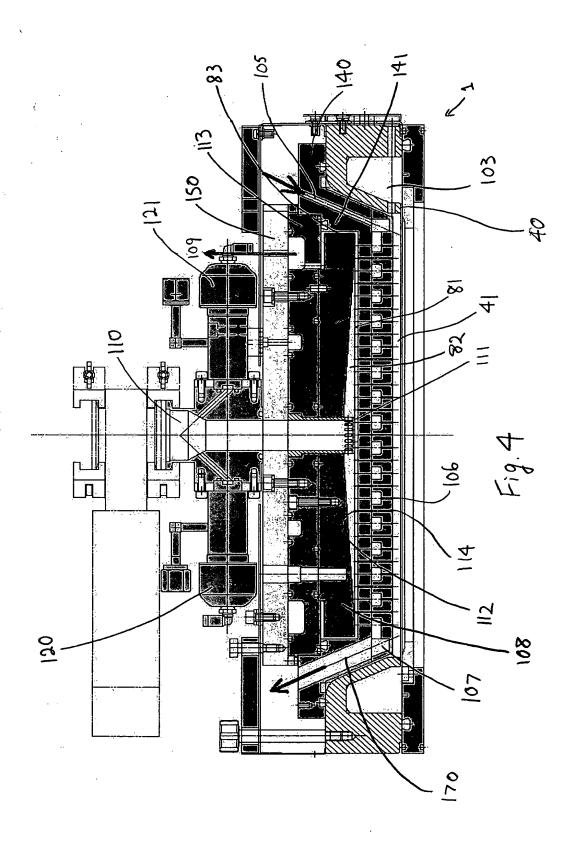


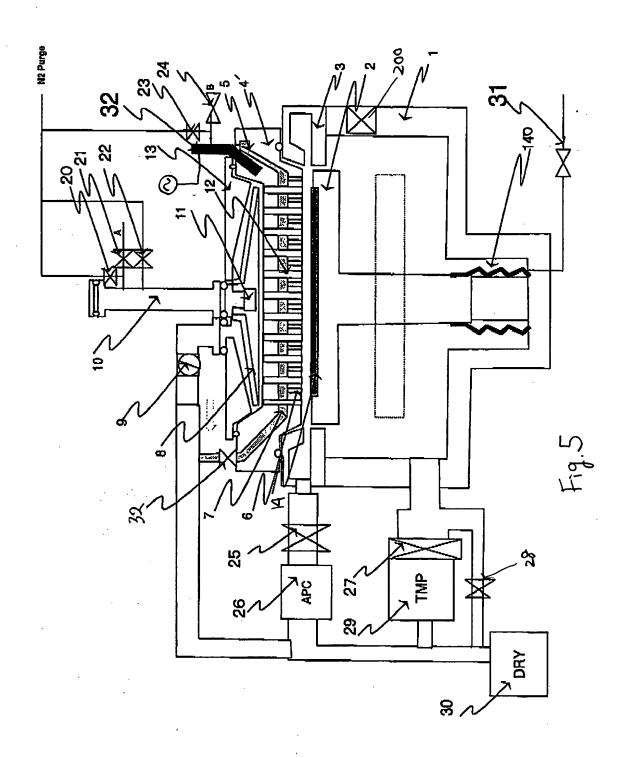
F.g.2

THIN-FILM DEPOSITION APPARATUS Hiroshi SHINRIKI, et al. o.: Unknown Atty Docket: ASMJP.149AUS

Appl. No.: Unknown

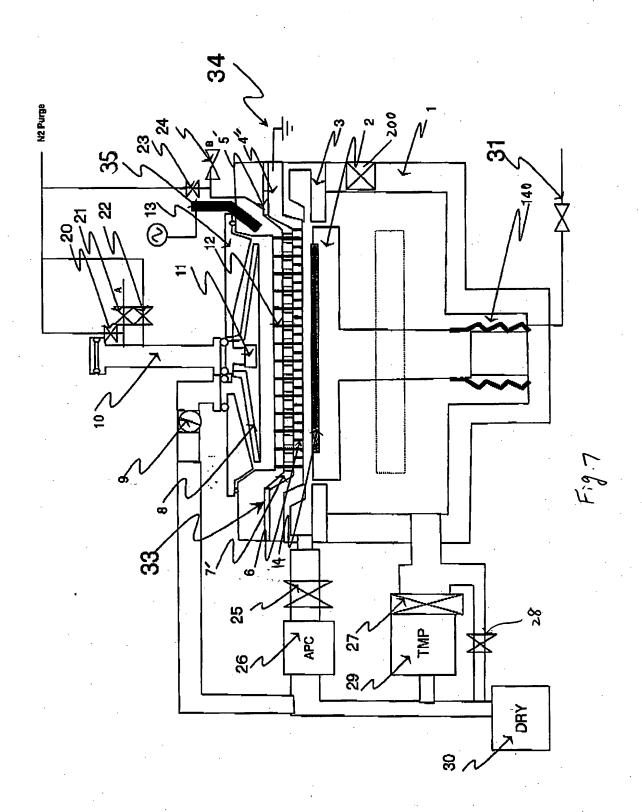
		step1	step2	step3	step4	step5	step6	step7
-	Time	set time	set time	set time	set time	set time	set time	set time
	20 or	uado	oben	open	open	open	oben	oben
	21	close	open	close	close	close	close	close
orlor oca	22 cl	close	close	close	open	close	close	close
gas valve	23	open	oben	oben	open	open	open	open
	24 cl	close	esop	close	close	close	open	close
vacuum	25 or	open	open	open	oben	open	open	open
exhaust	6	9 close	close	open	open	close	close	close
valve	32 ck	close	close	close	close	close	close	open





THIN-FILM DEPOSITION APPARATUS Hiroshi SHINRIKI, et al. Appl. No.: Unknown Atty Docket: ASMJP.149AUS

) () ()		step {	step2	step3	step4	step5	step6	step?	step8	step9
	Time	set time	set time	၂ မ	set time					
gas valve	20	20 open	open	open	oben	open	open	open	open	open
	21	21 close	open	close	close	close	close	close	close	close
,	22	22 close	close	close	open	close	close	close	close	close
	23	23 open	open	open	oben	open	oben	open	open	open
,	24	24 close	close	close	esop	close	oben	open	open	close
Plasma		<i>ڪو</i>	ofe	مدد	مديد	ore	ore	no (130 mg	1 Off
vacuum ?		25 open	open	open	uedo	open	open	open	open	oben
exhaust	6	9 close	close	open .	open	close	close	close	close	close
valve	32	32 close	close	close	close	close	close	close	close	open



THIN-FILM DEPOSITION APPARATUS
Hiroshi SHINRIKI, et al.
Appl. No.: Unknown Atty Docket: ASMJP.149AUS

